PRODUCT EXAMPLES



Outline of OKAZAKI



Company Name: OKAZAKI MANUFACTURING COMPANY

Head office : 1-3,Gokodori,3-Chome,Cyuo-Ku Kobe,651-0087,Japan

Established : January 26,1954

Line of business: Temperature measuring sensors, Industrial heaters

and Mineral insulated cable

Domestic factories: Akashi, Kobe-Iwaoka, Kobe-Nishi, Fukuoka and Kyusyu

International group companies:

ARi Industries, Inc.(USA)

Okazaki Manufacturing (Taiwan) Co.,Ltd

Okazaki Manufacturing Co., European Office

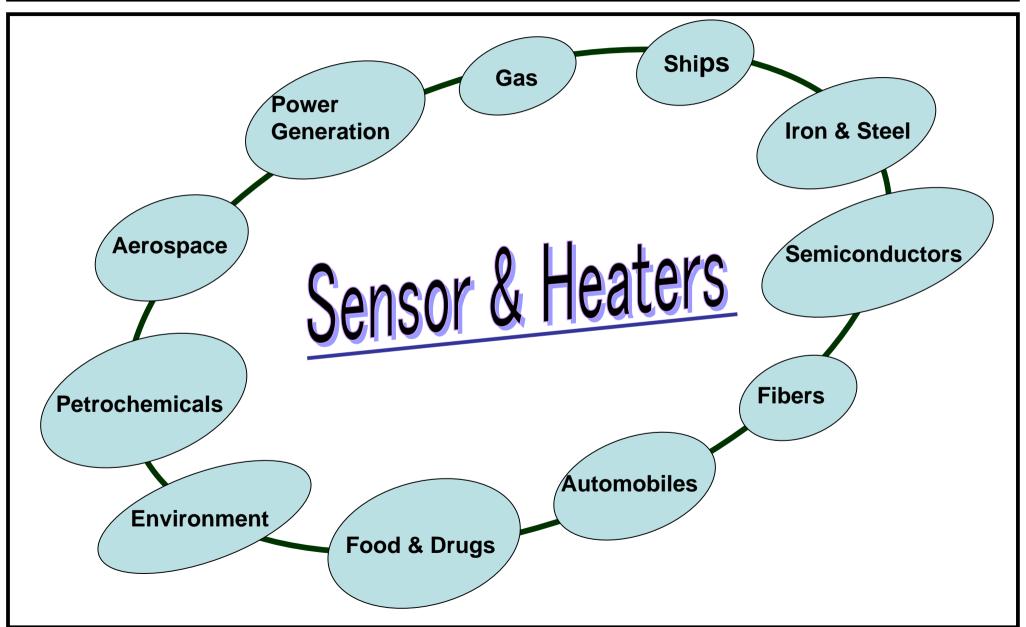
OKAZAKI'S achievement in FY 2008:

OMC only: \$130.0 million

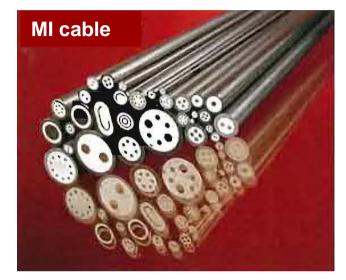
OMC group consolidated: \$189.0 million

To all industrial fields





Temperature sensor & Electrical heater for general use



Core:

Ni,Ni-Cr Alloy or Others

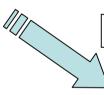




Thermocouples



Core : Nickel or Copper



Core : Ni-Cr Alloy or Others









Supplied with Temperature Transmitter

Resistance Temperature Detectors

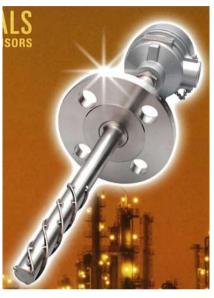
Temperature sensor for special use(1/2)



Temperature Sensor for Low Temperature Storage Tank(LNG,LPG)



Explosion/ Frame Proof Temperature Sensor



Temperature Sensor for Petrochemicals



Temperature Sensor for Nuclear use

Temperature sensor for special use (2/2)



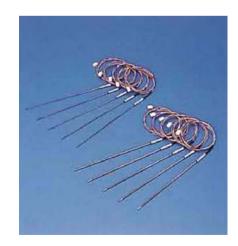
The World's smallest diameter mineral insulated thermocouples

Sheath diameter (mm)	0.08	0.10	0.25			
Insulation resistance	>1	MΩ/3V	DC	>10MΩ ∕ 50VDC		
Response time (RT→Boiling water、63.2%)	<1ms 1ms 2ms			4ms		
Maximum temperature		400°C	500℃			

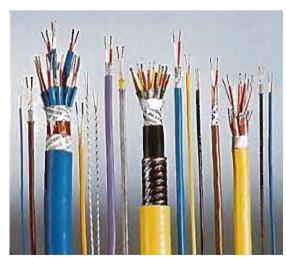
Usable up to 1000°C for short-period use (Disposable Type)



Thermocouples for high temperature: 2200°C(max)



Thermocouples for fuel cell



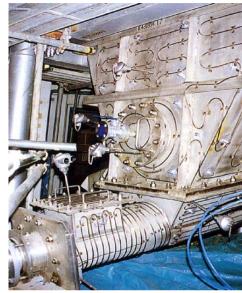
Compensating & Lead Wire

Electrical heaters

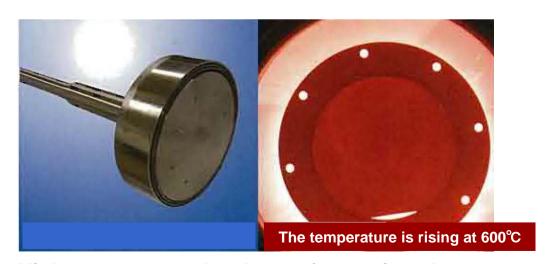


Nuclear fuel rod simulation heaters





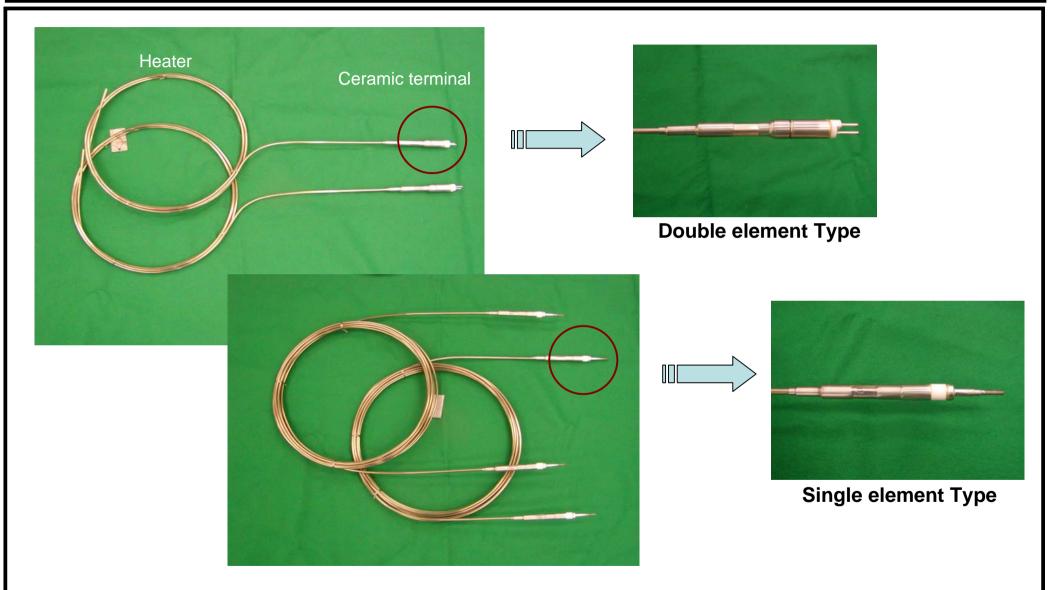
Micro - Heater Assembly



High temperature plate heater for semiconductors

Baking heaters for vaccum chamber

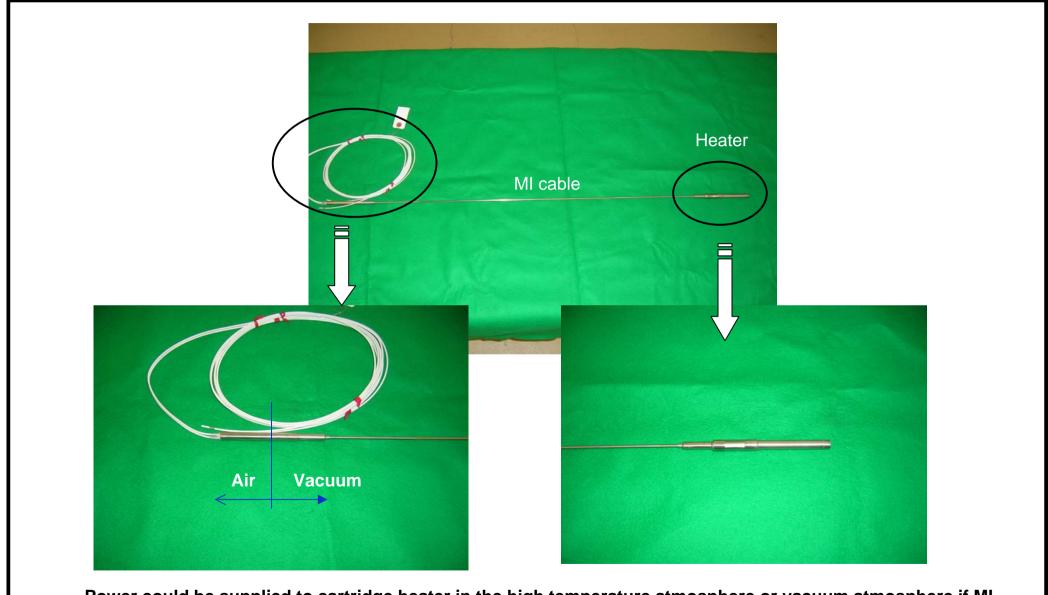




Ceramic terminal is used at end of the heater, and it is connectable to power supply in vaccum atmosphere

Cartridge heaters





Power could be supplied to cartridge heater in the high temperature atmosphere or vacuum atmosphere if MI cable is connected to cartridge heater. (Self-contained termocouple is also available)

Introduce of Mineral Insulated cable

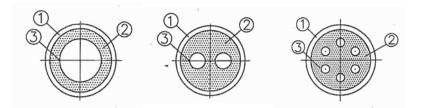




We can design and manufacture MI cable for heater, thermocouple and extension wire in response to various request from customer.

Typical MI cable for power, control & Instrumentation





1	Sheath	316ss or Others
2	Insulation	MgO
3	Element	Cu

	0000000000	Sheath	Cond	luctor	Missarcai di	0 0 1 1 0 0 0 0 0 1 0 0 0	Dielectric	Y 2023 1 2 4 4 5 2	Approx.	Standard
Model	Conductor number	diameter (mm)	Sectional area (mm ²)	Diameter (mm)	Nominal wall thickness (mm)	Conductor resistance (Ω ∕km∶at 20°C)	strength value (VAC)	Insulation distance (mm)	Mass (g/m)	length (m)
MI- 61/4		6.6	4	2.31		4.51			195	111
MI- 61/6		7.3	6	2.79		3.10			245	91
MI- 61/10	1.	8.4	10	3.60		1.86			338	68
MI- 61/16		9.5	16	4.52		1.18			451	53
MI- 61/25		11.1	25	5.68		0.75			638	39
MI- 62/4		11.4	4	2.32		4.49			556	37
MI- 62/6		12.8	6	2.78		3.11			711	29
MI- 62/10	2	14.9	10	3.62		1.84			990	21
MI- 62/16		17.4	16	4.54	100 6	1.17		KE 7 L 11	1378	16
MI- 62/25		20.3	25	5.66	Approx.12% of sheath O.D.	0.75	2500	Not less than 1.30	1916	12
MI- 63/4		12.2	4	2.31	Sileaul O.D.	4.51		1.50	656	32
MI- 63/6		13.6	6	2.82		3.03			835	26
MI- 63/10	3	15.9	10	3.64		1.82			1177	19
MI- 63/16		18.4	16	4.54		1,17			1619	14
MI- 63/25]	21.7	25	5.67		0.75	1		2305	10
MI- 64/4		13.4	4	2.30]	4.55]		801	28
MI- 64/6] ,	15.1	6	2.86		2.94	1		1047	22
MI- 64/10	4	17.6	10	3.65		1.80	1		1466	16
MI- 64/16		20.5	16	4.53		1.17			2035	11

Example: MI-61/4

Sectional area (mm ²)

Element number

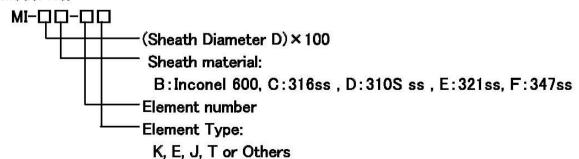
Voltage (AC600V)

Standard bend radius R = 6*D (D: Sheath diameter)

Typical MI cable for thermocouple

Model	Pair number	Sheath diameter D (mm)	Nominal wall thickness (mm)	Element diameter (mm)	Insulation resistance test (MΩ)	Sheath Material	Approx. Mass (g/m)	Standard length (m)
		0.25	0.035	0.05			0.3	100
		0.5	0.08	0.1			1.2	180
		1.0	0.17	0.17		316ss or Others	5	250
	1 1	1.6	0.27	0.27	> 100		10	100
MI		3.2	0.47	0.51			45	370
	1	4.8	0.72	0.76			100	160
	1	6.4	0.93	1.0			180	90
	;	8.0	1.16	1.3			280	60
		3.2	0.47	0.51			45	370
MI-00-40	2	4.8	0.72	0.76			100	160
MJ-LJ LJ-4LJ		6.4	0.93	1.0			180	90
	1	8.0	1.16	1.3			280	60
		4.8	0.72	0.50			100	160
MI- -6	3	6.4	0.93	0.72			180	90
		8.0	1.16	0.90			280	60

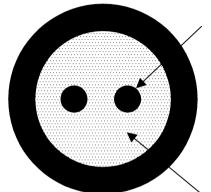
Model No.



[•]MI cable for thermocouple except shown on the above table are also available.

Ultra small diameter MI cable for thermocouples





Element : Type K

Ceramic Insulation

Super fine mineral insulated thermocouples

超極細
シース熱電対

Real scale

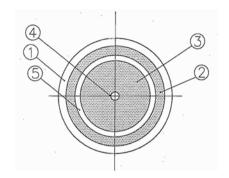
Human hair

Outer diameter comparison with human hair

Model	Pair	Sheat	th (mm)	Element diameter	Standard length	Sheath material
	number	Outer diameter	Wall thickness	(mm)	(mm)	Oneath material
MI-008B-2K		0.08	0.011	0.011	200	
MI-010B-2K	1	0.10	0.014	0.014	300	Inconel 600
MI-015B-2K		0.15	0.020	0.020	500	

Actual achievement of manufacturing coaxial MI cable





1	Outer sheath	316ss or Others
2	Outer insulation	MgO
3	Inner insulation	SiO2
4	Element	Cu
5	Inner sheath	316ss or Others



Cross-sectional surface of coaxial cable

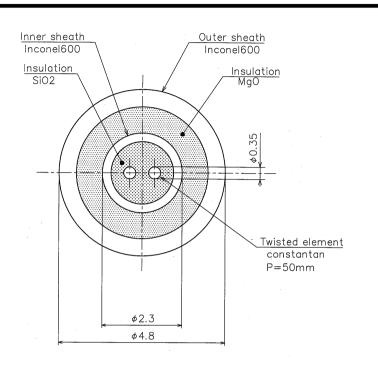
7C-2V Coaxial cable manufacturing results (Double stainless steel sheath)

3332	Conductor			1	inner sheath	6	Outer sheath			
Model	Element number	Sectional area (mm ²)	Diameter (mm)	Resistance (Ω/km:at20°C)	diameter (mm)	wall thickness (mm)	Insulation thickness (mm)	diameter (mm)	Wall thickness (mm)	Insulation thickness (mm)
MI-7C2V	1	0.52	0.81	<45	7.8	0.52	2.97	11.0	0.73	0.87

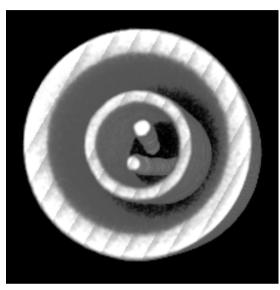
Model	Insulation resistance e test (M Ω) at 1KHz)		attenuation amount (dB / km : at 10MHz)	Characteristic impeadance (Ω)	Length (m) (Calculated value)
MI-7C2V	> 100	< 80	< 90	75±3	10

Standard bend radius R = 6*D (D:Outer sheath diameter)

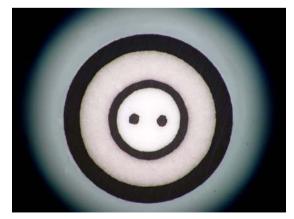
Double sheath twisted cable



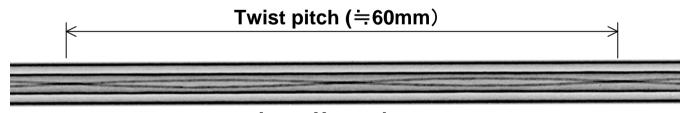




MicroFocus Photo image



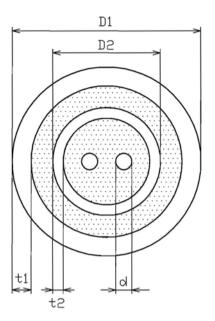
Cross sectional surface



Inner X-ray photo

Multicore cable is also available based on customer's specification

Double sheath twisted cable (Continue)



Explanation of symbol

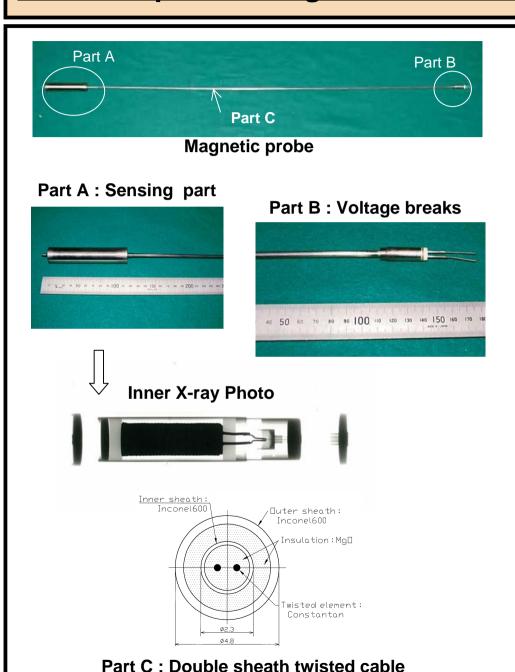
Double sheath twisted cable

Outer sheath			Inner sheath									
	Sh	Sheath			Sheath			Conductor			twisted	Length (m)
Diameter D1(mm)	Material	Wall thickness t1 (mm)	Insulation material	Diameter D2 (mm)	Material	Wall thickness t2 (mm)	Insulation material	ulation	Material	pitch (mm)	(Calculated value)	
6.4		≥0.64		3.65		≥0.36			≥0.55		(50)	10
4.8	316ss or Others	≧0.48	MgO or Others	2.7	316ss or Others	≧0.27	MgO or Others	2	≧0.41	Cu or Others	(50)	15
3.2		≥0.32		1.8		≥0.18			≥0.27		(100)	40

Standard bend radius R= 6*D1 (D1: Outer sheath diameter)

Probe for plasma magnetic fields measurement





The sensor ,which is one of the magnetic probes installed to fusion experimental reactor, is to detect component of magnetic field along wall of the vaccum vessel.

Specification

Sensing part: φ 22 × 108 L

- Interlinkage products: 0.334 m² (10~1KHz, 0.8~5 Gauss)

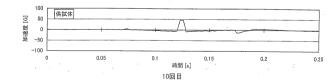
Heat proof temperature:300°C

Dieelectric withstanding voltage: DC200V, 1min

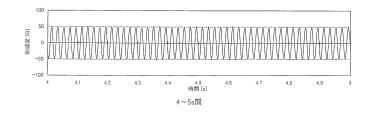
Characteristics:

Resistance to vibration occurs in magnetic field

 Impact resistance: 50G (trapezoidal wave 16ms,Repeat 10 times)



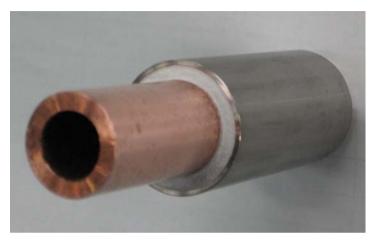
 Vibration resistance:50G (Sine wave, 50Hz, Vibration time 5s, Repeat 10 times)



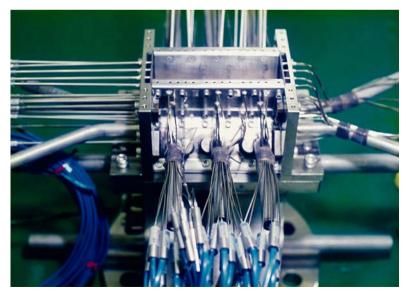
Usage example of MI cable



Connecting operation of MI cable and connector



MI cable with water-cooled tube



Temperature & pressure measuring experimental machine



MI cable aggregate

Usage example of MI cable



Coaxial cable in cell



7C2V Coaxial cable



Laying operation of MI cable which penetrates the wall



Connector box for MI cable

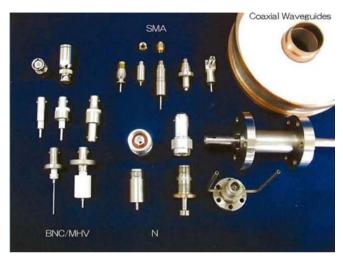


Plug for power manipulator

Connector & Feedthrough



Multi pins & Connectors



Coaxial feedthrough



Voltage breaks



Feedthrough for power supply



MI cable connectors

Connector & Feedthrough



For power supply



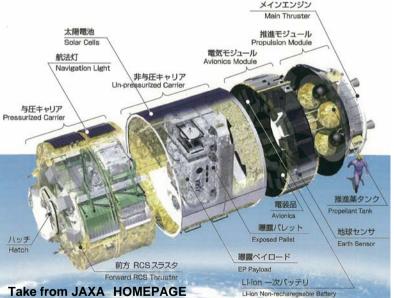
Voltage breaks



For power supply

Temperature sensors for aerospace





Sensor for aerospace instruments are manufactured in a clean room. They are installed in H-II A,H-II B rocket or satellites, and have excellent capabilities for measuring temperatures from -260°C to +930°C,also,we manufactures liquid gas sensors that are mounted on rocket fuel tanks(LH2,LO2) in the H-II A, H-II B rocket.



Temperature Sensor for Aerospace

Temperature calibration system



Temperature calibration system



Calibration range: 40 ~500°C Stability: ±0.1°C



Calibration range: 100 ~650°C Stability: ±0.05°C



Calibration range: 400 ~1000°C (1100°Cmax)

Stability: ±0.05°C

We also carry temperature calibration devices (bath and dry-well type) of **FLUKE**

Environment and Quality control



We are certified company of ISO 14001 & ISO 9001

We are committed to Green Procurement in order to eliminate hazardous chemical substance in our product.



Awarded ISO 14001 for Environmental Management System (Approval certificate No: YKA0772497)

Approved factories: Akashi, Kobe-iwaoka



Awarded ISO 9001 for Quality Management System (Approval certificate No: YKA0925432)

Approved factories: Akashi, Kobe-iwaoka, Fukuoka